WEST Search History

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DATE: Monday, November 06, 2006

Hide?	Set Name	Query	Hit Count
		DB=PGPB,USPT,USOC; PLUR=YES; OP=ADJ	
☐	L19	L18 and l17	7
☐	L18	134/26,30,31,33,36,902.ccls.	6219
☐	L17	L16 same (robot$3 or arm)	21
☐	L16	(wafer or semiconductor or substrate or article) same (rotat$4 or circulat$3) same (wash$3 or rins$) same (dry$3 with gas$4)	390
		DB=EPAB,JPAB,DWPI; PLUR=YES; OP=ADJ	
☐	L15	L14 same (robot$3 or arm)	3
☐	L14	(wafer or semiconductor or substrate or article) same (rotat$4 or circulat$3) same (wash$3 or rins$) same (dry$3 with gas$4)	69
☐	L13	(wafer or semiconductor or substrate or article) same (rotat$4 or circulat$3) same rins$3 same (dry$3 with gas$4)	25
☐	L12	(wafer or semiconductor or substrate or article) same (rotat$4 or circulat$3) same rins$3 same dry$3	195
		DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI; PLUR=YES; OP=ADJ	
☐	L11	L10 or l9 or l8 or l7	14
☐	L10	kao-yao-hwan$.in.	11
☐	L9	huang-po-chang$.in.	3
☐	L8	hung-ming-yeon$.in.	5
☐	L7	huang-chi-che$.in.	1
☐	L6	huang-chi$.in.	2295
☐	L5	hung-ming$.in.	304
☐	L4	huang-po$.in.	82
☐	L3	kao-yao$.in.	20
		DB=PGPB; PLUR=YES; OP=ADJ	
☐	L2	L1 and hb	1
☐	L1	20050211267	1

END OF SEARCH HISTORY